

WEST Search History

DATE: Tuesday, February 03, 2004

| Hide? | <u>Set</u> <u>Name</u> | <u>Query</u> | <u>Hit</u> <u>Count</u> |
|--------------------------|--|---|----------------------------|
| | <i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i> | | |
| <input type="checkbox"/> | L15 | L2 and (HF same hydrophobic) | 3 |
| <input type="checkbox"/> | L14 | L2 same HF same hydrophobic | 1 |
| <input type="checkbox"/> | L13 | L12 and l2 | 19 |
| <input type="checkbox"/> | L12 | L11 or l1 | 11231 |
| <input type="checkbox"/> | L11 | 134/902;438/906.ccls. | 2476 |
| <input type="checkbox"/> | L10 | 257/E21.228.ccls. | 0 |
| <input type="checkbox"/> | L9 | L8 and l1 | 2 |
| <input type="checkbox"/> | L8 | (ozon\$5 water) and SC1 and rins\$3 and (HF or hydrogen fluoride) and (dry\$3 with IPA) | 4 |
| <input type="checkbox"/> | L7 | (ozon\$5 water) same SC1 same rins\$3 same (HF or hydrogen fluoride) same (dry\$3 with IPA) | 1 |
| <input type="checkbox"/> | L6 | (ozon\$5 water) same SC1 same rins\$3 same (HF or hydrogen fluoride) same (dry\$3 with IPA) | 0 |
| <input type="checkbox"/> | L5 | L2 same (HF or hydrogen fluoride) | 3 |
| <input type="checkbox"/> | L4 | L2 same clean\$3 same etch\$3 | 8 |
| <input type="checkbox"/> | L3 | L2 same clean\$3 | 44 |
| <input type="checkbox"/> | L2 | (substrate or wafer or semiconductor) same ((pre-epi\$7) or pre epi\$7) | 71 |
| <input type="checkbox"/> | L1 | 134/2,3,26,28,41;216/96,99,108,109.ccls. | 9150 |

END OF SEARCH HISTORY

Patent Assignment Abstract of Title

Total Assignments: 2

Application #: 10091011 **Filing Dt:** 03/04/2002 **Patent #:** NONE **Issue Dt:**
PCT #: NONE **Publication #:** 20030019507 **Pub Dt:** 01/30/20
Inventors: Ismail Kashkoush, Gim-Syang Chen, Richard Ciari, Richard E. Novak
Title: Cleaning and drying method and apparatus

Assignment: 1

Reel/Frame: 012668/0631 **Received:** 03/18/2002 **Recorded:** 03/04/2002 **Mailed:** 05/08/2002 **Pages**

Conveyance: ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).

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Exec Dt: 02/28/2002

CHEN, GIM-SYANG

Exec Dt: 02/28/2002

CIARI, RICHARD

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Assignment: 2

Reel/Frame: 013758/0519 **Received:** 06/27/2003 **Recorded:** 06/27/2003 **Mailed:** 06/30/2003 **Pages:**

Conveyance: SECURITY INTEREST (SEE DOCUMENT FOR DETAILS).

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Search Results as of: 2/3/2004 4:57:59 P.M.